09/869347 Rec'd PCT/PTO 2 8 JUN 2001

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June 28, 2001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): UCHIDA, et al.

MATERIALS FOR POLISHING LIQUID FOR METAL, POLISHING LIQUID FOR METAL, METHOD FOR PREPARATION THEREOF AND POLISHING METHOD USING June 28, 2001 Filed: For:

THE SAME

## PRELIMINARY AMENDMENT

Assistant Commissioner for Patents Washington, D.C. 20231

sir:

please amend the above-identified application, prior to

examination thereof, as follows: 1754 西西西哥中方,西西西河河

please delete the paragraph from page 10, line 25 to page IN THE SPECIFICATION

11, line 4, and substitute therefor the following new

paragraph:

-- The salts of carboxylic acids include soap, salts of N-

acylamino acids, polyoxyethylene alkyl ether-carboxylates, polyoxypropylene alkyl ether-carboxylates, acylated peptides,

etc.--

please delete the paragraph from page 12, line 10 to page

11, line 12, and substitute therefor the following new

paragraph:

-- In addition, the following surfactants are also